

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Park, Young-woo; Noh, Jun-yong; Koo, Bon-young;  
Kang, Chang-jin; Jung, Chul; Nam, Seok-woo  
Assignee: Samsung Electronics Co., Ltd.

Title: Semiconductor Memory Device And Method Of Manufacturing For  
Preventing Bit Line Oxidation

Serial No.: 09/008,525 Filed: 01/16/98 **FAX RECEIVED**  
Examiner: Not Assigned Group Art Unit: 2811 **APR 13 2001**  
Docket No.: AB-778 US **PETITIONS OFFICE**

San Jose, California  
March 21, 2000

ASSISTANT COMMISSIONER FOR PATENTS  
Washington, D. C. 20231

**INFORMATION DISCLOSURE STATEMENT WITH  
CERTIFICATION UNDER § 1.97(e)(1)**

Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, Applicant(s) wish to call the following documents (copies enclosed) to the attention of the Examiner. The documents were cited in the enclosed European Search Report for the corresponding European Application No. EP 98 30 0304.

A PTO form 1449 listing these documents is enclosed.

The relevance of any non-English language documents cited herein is explained in the accompanying copy of the Abstract.

Citation of the above documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, other than as described above; or

3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

The undersigned hereby certifies in accordance with § 1.97(e)(1) that each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: ASSISTANT COMMISSIONER FOR PATENTS, Washington, D.C. 20231, on March 21, 2000.

*David Millers* 3-21-00  
Attorney for Applicants Date of Signature

Respectfully submitted,

*David Millers*

David T. Millers  
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Reg. No. 37,396

Sheet

U.S. Department of Commerce, Patent and Trademark Office		Att'y Docket No.	Serial No.
		AB-778 US	09/008,525
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant(s)	
(Use several sheets if necessary)		Park, Young-woo; Noh, Jun-yong; Koo, Bon-young; Kang, Chang-jin; Jung, Chul; Nam, Seok-woo	
		Filing Date	Group
		01/16/98	

## U.S. Patent Documents

*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
AA	5,126,280	06/30/92	Chan et al.	437	52	
AB	5,196,364	03/23/93	Fazan et al.	437	52	
AC	5,330,614	07/19/94	Ahn	156	631	
AD	5,445,999	08/29/95	Thakur et al.	437	242	FAX RECEIVED
AE						
AF						APR 13 2001
AG						PETITIONS OFFICE
AH						
AI						
AJ						
AK						

## Foreign Patent Documents

		Document	Date	Country	Class	Subclass	Translati n
	AL	EP 0 539 233	04/28/93	Europe	HO1L		Yes
	AM						
	AN						
	AO						
	AP						

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AQ	Japanese Abstract - Manufacture Of Semiconductor Storage Device, 1 page; Publication Number: 09139478; Publication Date: May 27, 1997
AR	
AS	

Examiner Date Considered

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.